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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PPLICATION OF:

: GROUP: 2812

Sei TSUNODA, et al.

SERIAL NUMBER: 09/942,626

: ATTENTION:

Application Division
Customer Corrections

FILED: AUGUST 31, 2001

INSULATION FILM BETWEEN SEMICONDUCTOR LAYERS USING THE SAME,

AND SEMICONDUCTOR DEVICE

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

FOR: LOW DIELECTRIC CONSTANT MATERIAL HAVING THERMAL RESISTANCE,

Assistant Commissioner for Patents Washington, D.C. 20231

TO 1700 PO

Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the attached. If you have any questions, please do not hesitate to contact us.

No fees are required. However, in the event that a fee is required, please charge the appropriate amount to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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22850

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COMMISSIONER FOR PATENTS STATES PATENT AND TRADEMARK OFFICE DN. D.C. 20231

APPLICATION NUMBER FILING DATE GRP ART UNIT FIL FEE REC'D ATTY.DOCKET.NO **DRAWINGS** 09/942,626 08/31/2001 2812 840

213480US0

IND CLAIMS

22850 OBLON SPIVAK MCCLELLAND MAIER & NEUSTADT PC FOURTH FLOOR 1755 JEFFERSON DAVIS HIGHWAY ARLINGTON, VA 22202 DEC 1 9 2001

CONFIRMATION NO. 8767 UPDATED FILING RECEIPT

Date Mailed: 12/03/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

MITSUBISHI DENKI KABUSHIKI KAISHA, Chiyoda-ku, JAPAN;

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C 1700 EL DEC 0 5 2001 OBLON, SENAK, M MCCLELLANDIA & NEUSINAIN STADT, P.C.

Title

Low dielectric constant material having thermal resistance, insulation film between semiconductor layers using the same, and semiconductor device

Preliminary Class

438

PLEASE NOTE THAT THE FOREIGN APPLICATION INFORMATION IS NOT BEING CLAIMED.

DELETE: JAPAN 153600/1999 01/06/99